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Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				<b>Complete If Known</b>	
				Application Number	10/729,357-Conf. #8259
				Filing Date	December 5, 2003
				First Named Inventor	John L. Klocke
				Art Unit	1745
				Examiner Name	H. D. Wilkins
				Attorney Docket Number	291958238US
Sheet	10	of	11		

HW	BT	JP-1048442	02-22-1989	Texas Instru Japan		✓
	BU	JP-5146984	06-15-1993	Murata Mach Ltd.		✓
	BV	JP-7197299-A	08-01-1995	Casio Computer Co. Ltd.		✓
	BW	JP-4311591	11-04-1992	Sumitomo Metal Ind. Ltd.		✓
	BX	JP-10-083960	03-31-1998	Takashi		✓
	BY	JP-7113159-A	05-02-1995	Canon Inc.		✓
	BZ	JP-6073598-A	03-15-1994	Suganuma Kelichiro		✓
	BA1	JP-11080993-A	03-26-1999	Ebara Corp		✓
	BB1	JP-5195183-A	08-03-1993	Mitsubishi Electric Corp		✓
	BC1	JP-4144150	05-18-1992	Ok Electric Ind Co Ltd		✓
	BD1	JP-6017291-A	01-25-1994	NEC Corp		✓
	BE1	JP-5211224	08-20-1993	Texan Instr Japan		✓
	BF1	JP-11036096-A	02-09-1999	NEC Corp		✓
	BG1	JP-6224202-A	08-12-1994	Ok Electric Ind Co. Ltd.		✓
	BH1	WO-02/99165	12-12-2002	Semitool, Inc.		
	BI1	WO-00/61498	10-19-2000	Wilson et al.		
	BJ1	WO-02/02908 WO-00/02808	01-20-2000	Semitool, Inc.		
	BK1	WO-02/97165	12-05-2002	Semitool, Inc.		
	BL1	WO-90/00476	01-25-1990	Tuckerman		
	BM1	WO-03/18874 WO-03/018874	09-03-2003	Semitool, Inc. 03-06-2003		
	BN1	WO-99/41434	08-19-1999	ACM Research, Inc.		
	BO1	WO-00/03072	01-20-2000	Woodruff et al.		
	BP1	WO-99/40615	08-12-1999	Ritzdorf et al.		
	BQ1	WO-02/17203	02-28-2002	Sabre, Inc.		
	BR1	WO-01/91163	11-29-2001	Semitool, Inc.		
	BS1	WO-95/06326	03-02-1995	Semitool, Inc.		
	BU1	WO-00/61837	10-19-2000	Wilson et al.		
	BV1	WO-01/90434	11-29-2001	Semitool, Inc.		
	BW1	WO-00/32835	06-08-2000	Dordi et al.		
	BX1	WO-99/25904	05-27-1999	Reid et al.		
	BY1	WO-99/25905	05-27-1999	Patton et al.		
	BZ1	WO-99/16936	04-08-1998	Semitool, Inc.		
	BA2	WO-00/02675	01-02-2000	Semitool, Inc.		
by	BC2	WO-91/04213	04-04-1991	Wong et al.		
	BD2	WO-01/46910	02-25-1990	The Regents of Univ of CA		
✓	BE2	WO-99/45745	09-10-1999	Armstrong et al.		
	BF2	WO-02/045476	06-13-2002	Semitool, Inc.		
HW	BG2	WO-95/20064	07-27-1995	Berg		

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. \* CITE NO.: Those application(s) which are marked with an asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.89(a)(2)(ii)) because that application was filed after June 30, 2003 or is available in the IFW. \* Applicant's unique citation designation number (optional). \* See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 801.04. \* Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \* For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. \* Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. \* Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature		Date Considered	
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